



Effective Etch Times and Compositional Effects on the Etching of Fossil Fission Tracks in Geological Apatite Samples

Florian Trilsch¹, Hongyang Fu^{1,2}, Raymond Jonckheere¹, Carolin Aslanian¹, Bastian Wauschkuhn¹, Lothar Ratschbacher¹
 florian.trilsch@gmx.net; fuhongyang@cug.edu.cn ¹TU Bergakademie Freiberg; ²China University of Geosciences, Wuhan

I. Introduction

- The fission-track method for determining ages and thermal histories of rocks is based on counting and measuring damage trails from Uranium fission
- These damage trails become visible by chemical etching, but questions remain how to relate the etched tracks to the actual damage
- A radial etch model with an apatite etch rate v_R and an along track etch rate v_T explains the geometries of etched fission tracks
- We explore how v_R and v_T scale with chemical composition, i.e. $Dpar$
- For samples with known $Dpar$, this allows to calculate effective etch times t_E of individual confined tracks from their widths and v_R ; this has several practical implications (see section IV.)

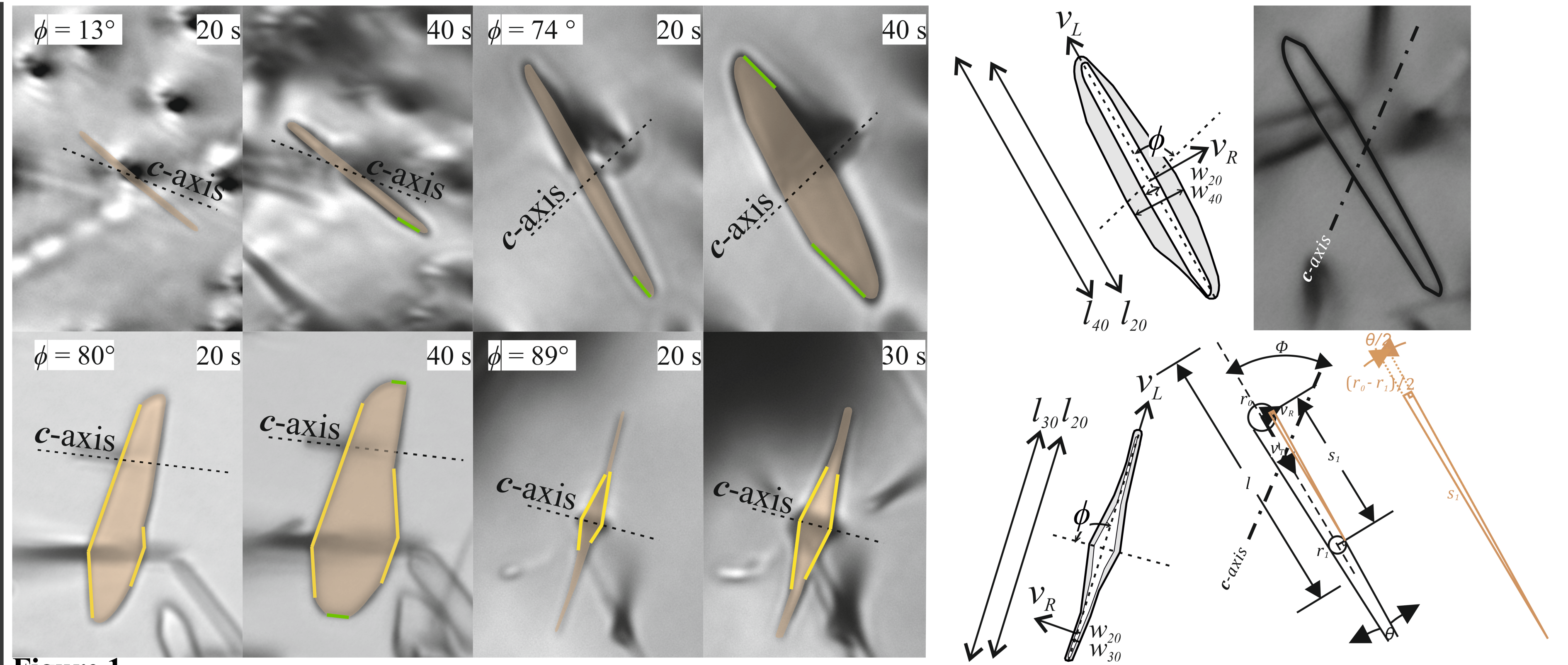
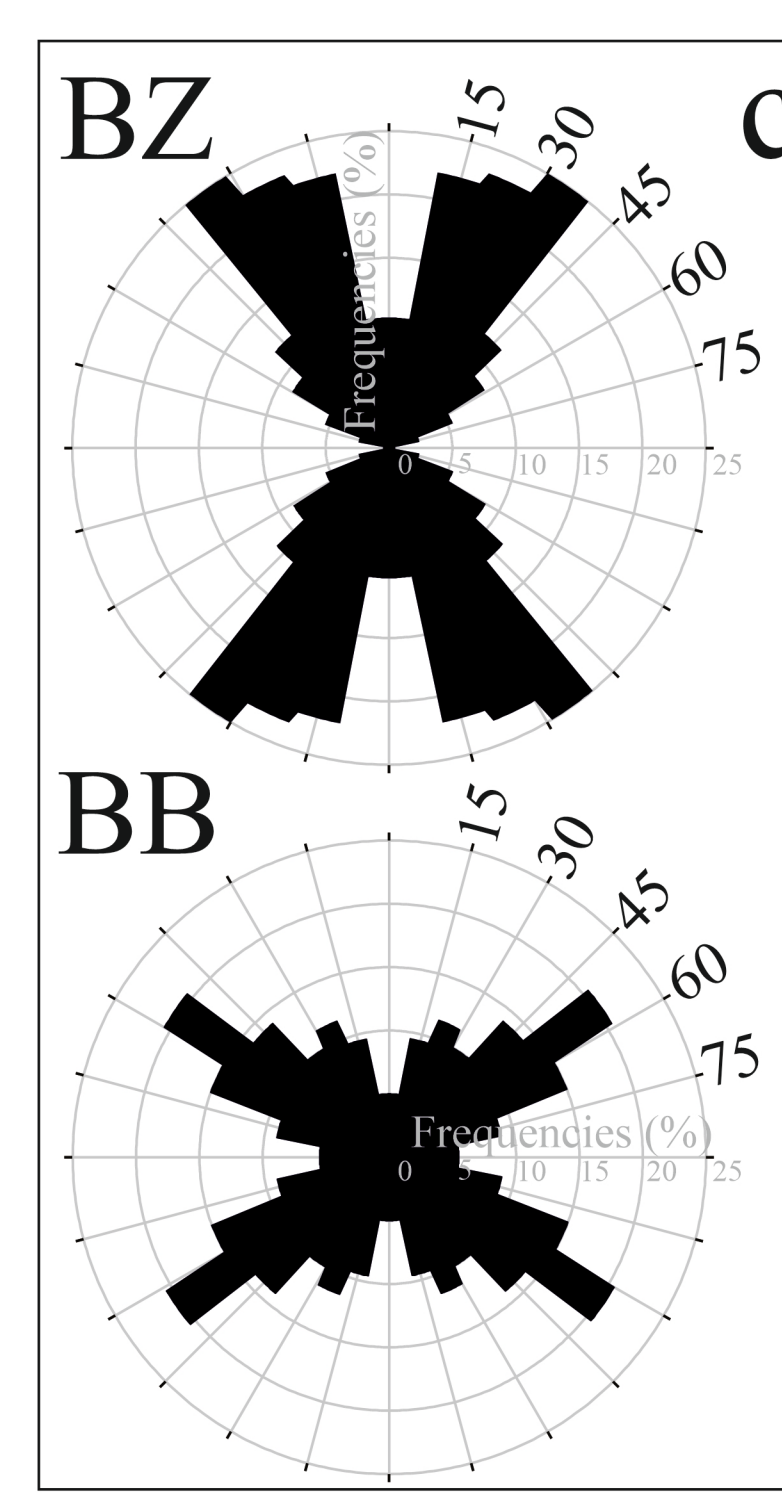
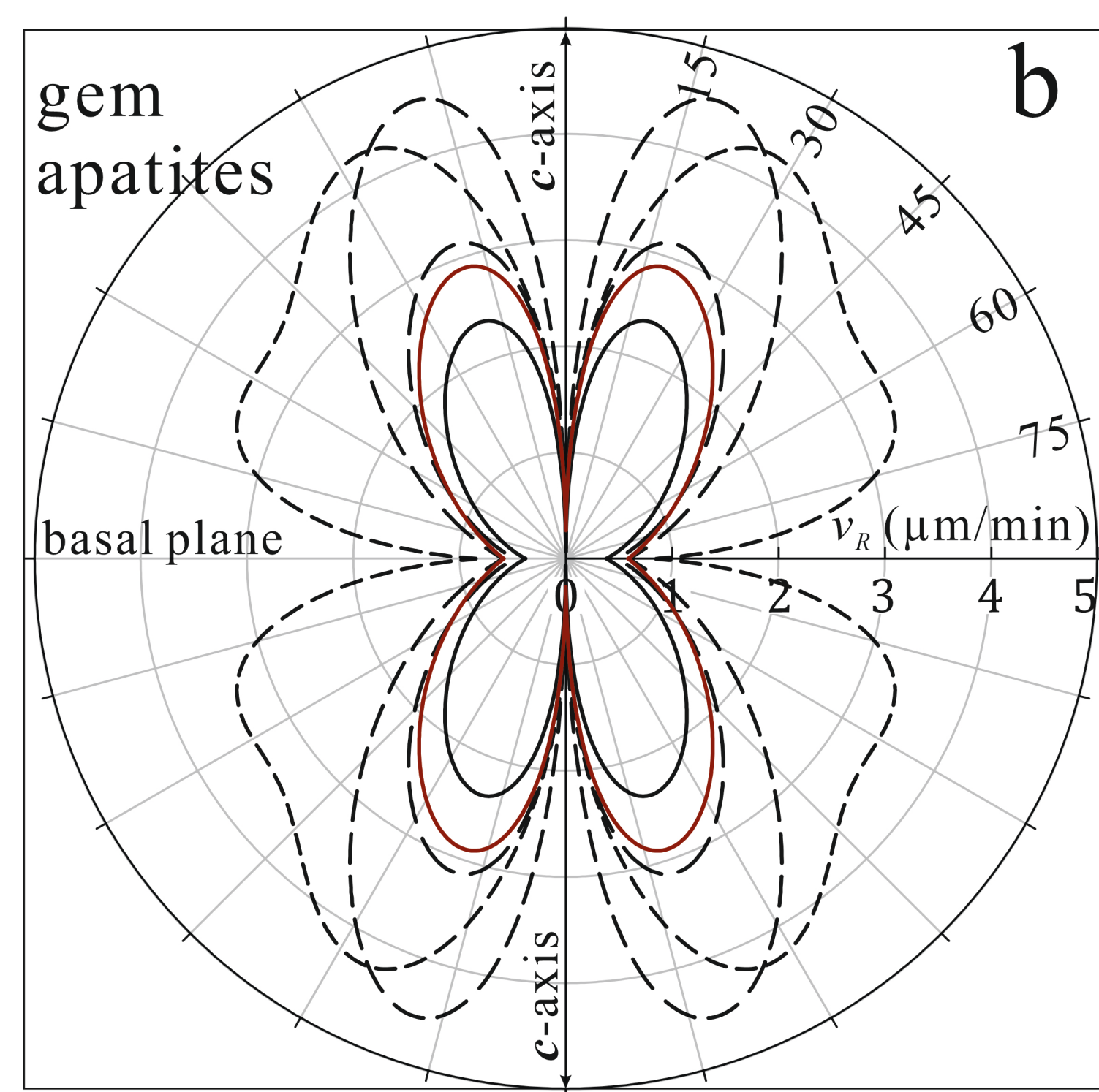
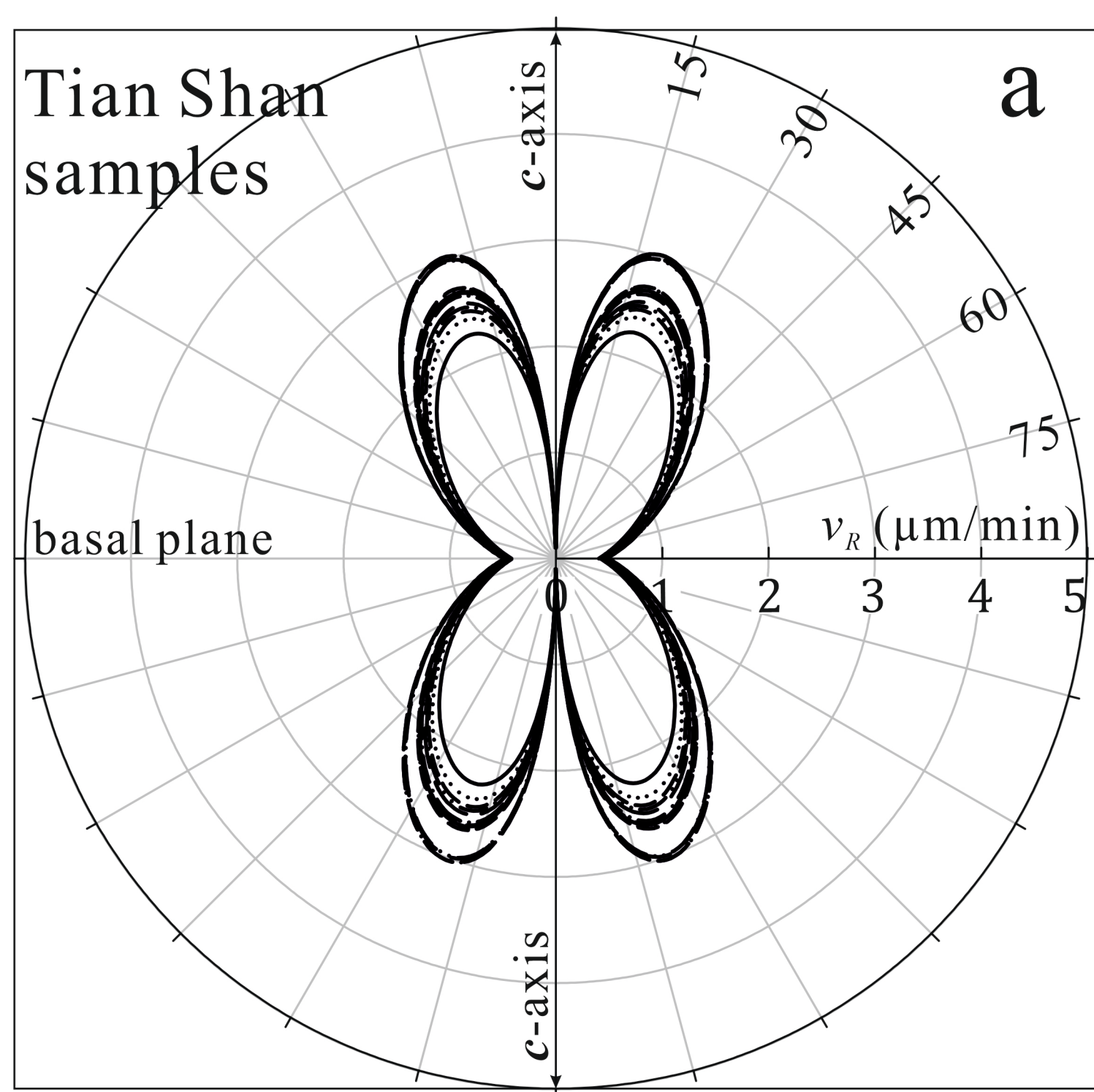


Figure 1.



II. The apatite etch rate v_R

- We conducted step-etch experiments to calculate v_R from width increases of confined tracks in prism faces of 14 samples from the southwestern Tian Shan ($Dpar = 1.4-2.7 \mu m$) and 4 gem apatites ($Dpar = 1.6-4.6 \mu m$) (Figure 1)
- v_R scales with $Dpar$ for all hexagonal apatites (Figure 2a-b):

$$v_R = (0.14 Dpar + 0.09) \phi' e^{(-0.0017 Dpar - 0.0470 \phi')} + 0.1$$
- This allows to calculate the apatite etch rate v_R and effective etch times for natural samples with known $Dpar$
- Monoclinic apatites show a different v_R pattern (Figure 2b)
- The rate of width increase controls the frequencies of tracks in a certain orientation (Figure 2c)

Figure 2.

III. The track etch rate v_T

- The track etch rate v_T is calculated from the angle between the facing straight track boundaries (Figure 1)
- v_T correlates with $Dpar$ (Figure 3a), suggesting that v_T is under chemical control rather than determined by the lattice damage along the track
- Track etch rates vary from track to track, suggesting an imprint of the thermal history on v_T
- Fossil tracks of samples with low average track etch rates are to different degrees under-etched compared to induced tracks using standard protocols (Figure 3b)
- The observations made above suggest the need to adjust immersion times for different samples (Figure 3c)

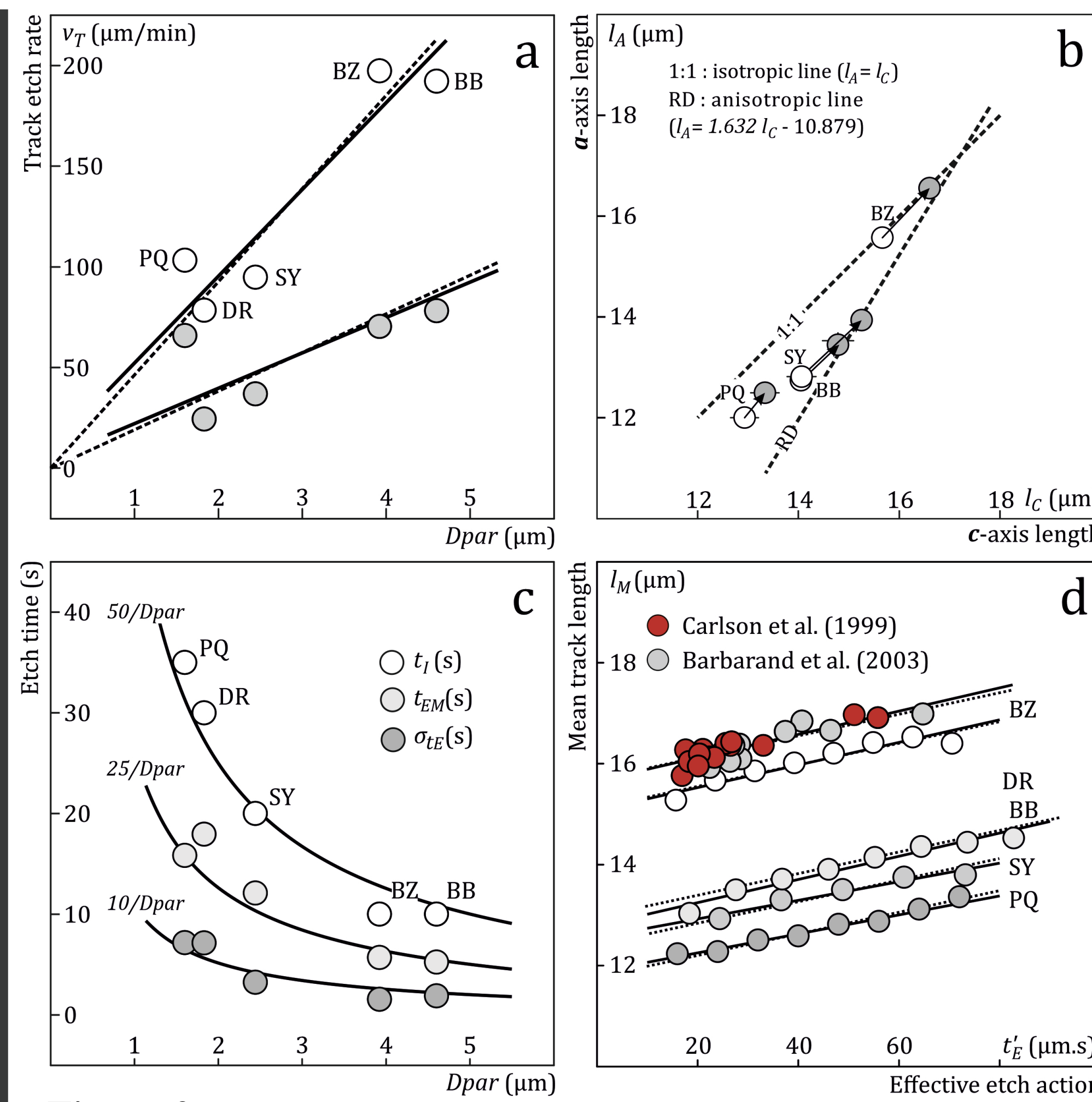


Figure 3.

IV. Implications

- Effective etch time calculations allow a quantitative selection of tracks within an etch-time window that excludes under- and over-etched tracks for T-t modelling (Figures 4 and 5)
- This approach allows to adjust the immersion time for individual samples with known $Dpar$:
 -> Longer immersion times or pooling of consecutive etch steps can increase the number of confined tracks for young and U-poor samples
- > Plots of c-axis projected length against orientation with a positive slope are a sign of under-etched fossil tracks; further etching lowers the slope and increases the agreement with induced tracks (Figure 5, left panel)
- For our samples T-t models with well-etched tracks ($t_E = 15-30 s$) fit better to independent AHe data than those with the conventional 20 s protocol (Figure 5, right panel)
- The initial mean length of unetched induced tracks is $\sim 15.6 \mu m$, independent of the apatite chemical composition (Figure 3d)

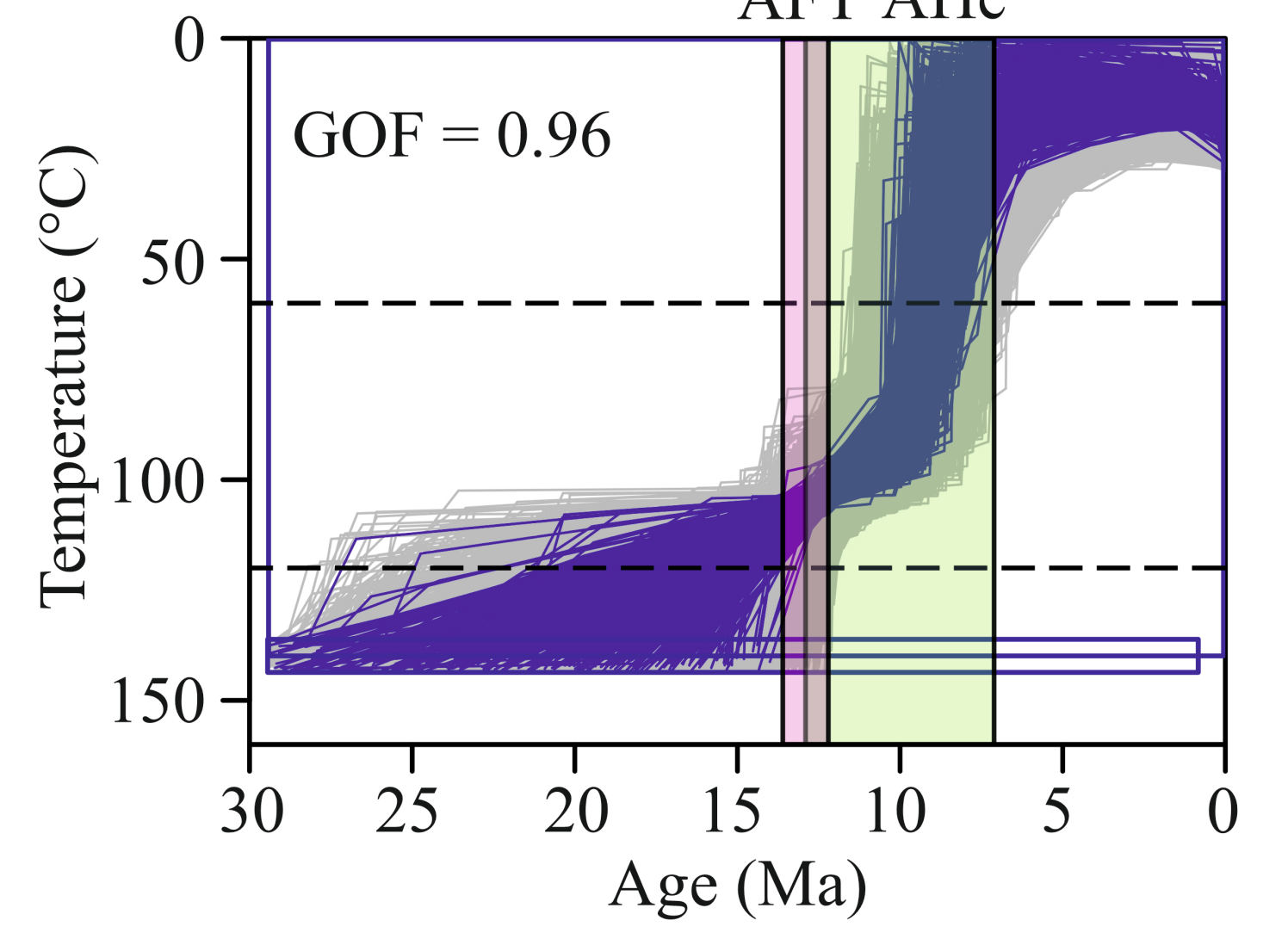
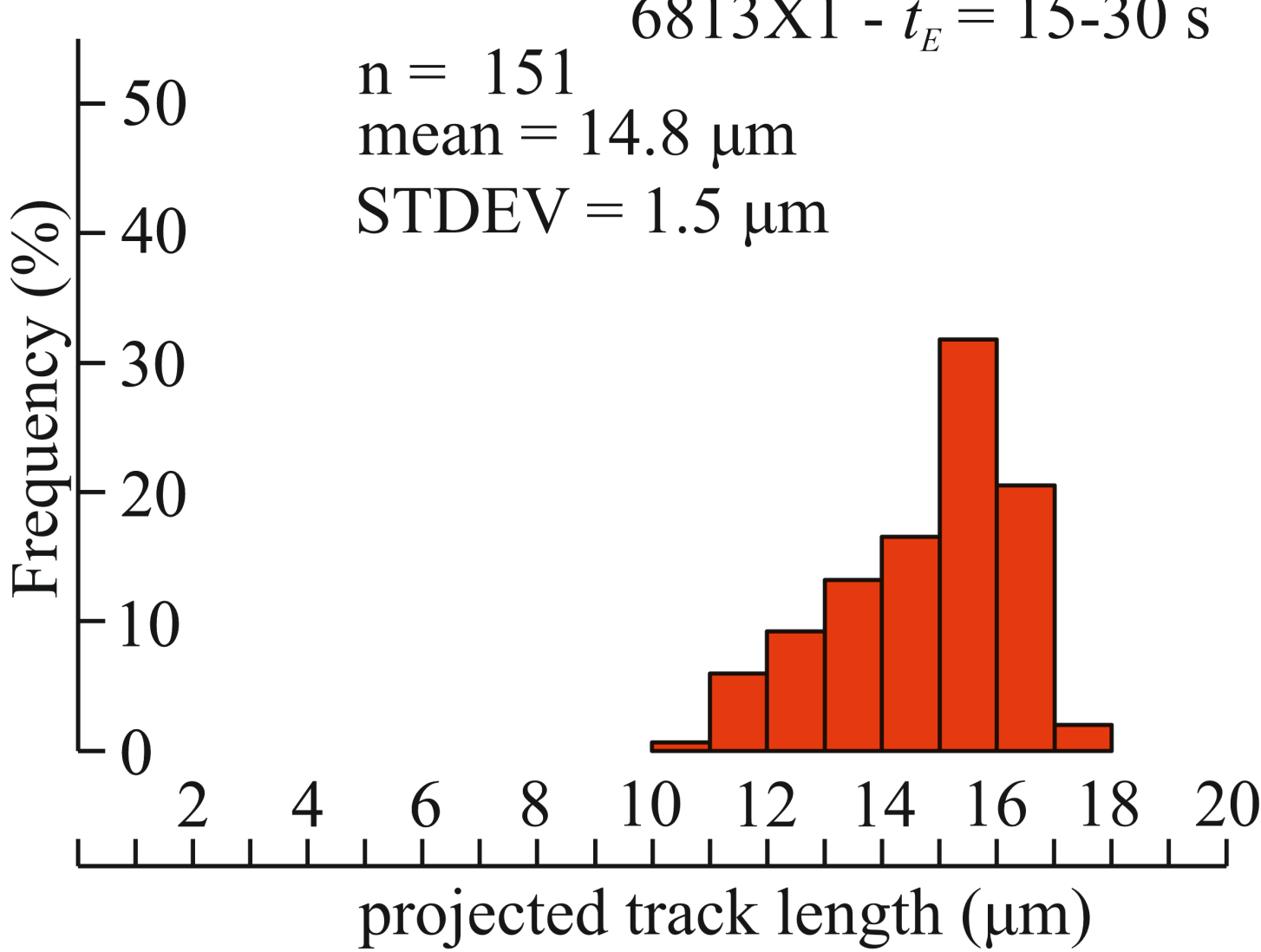
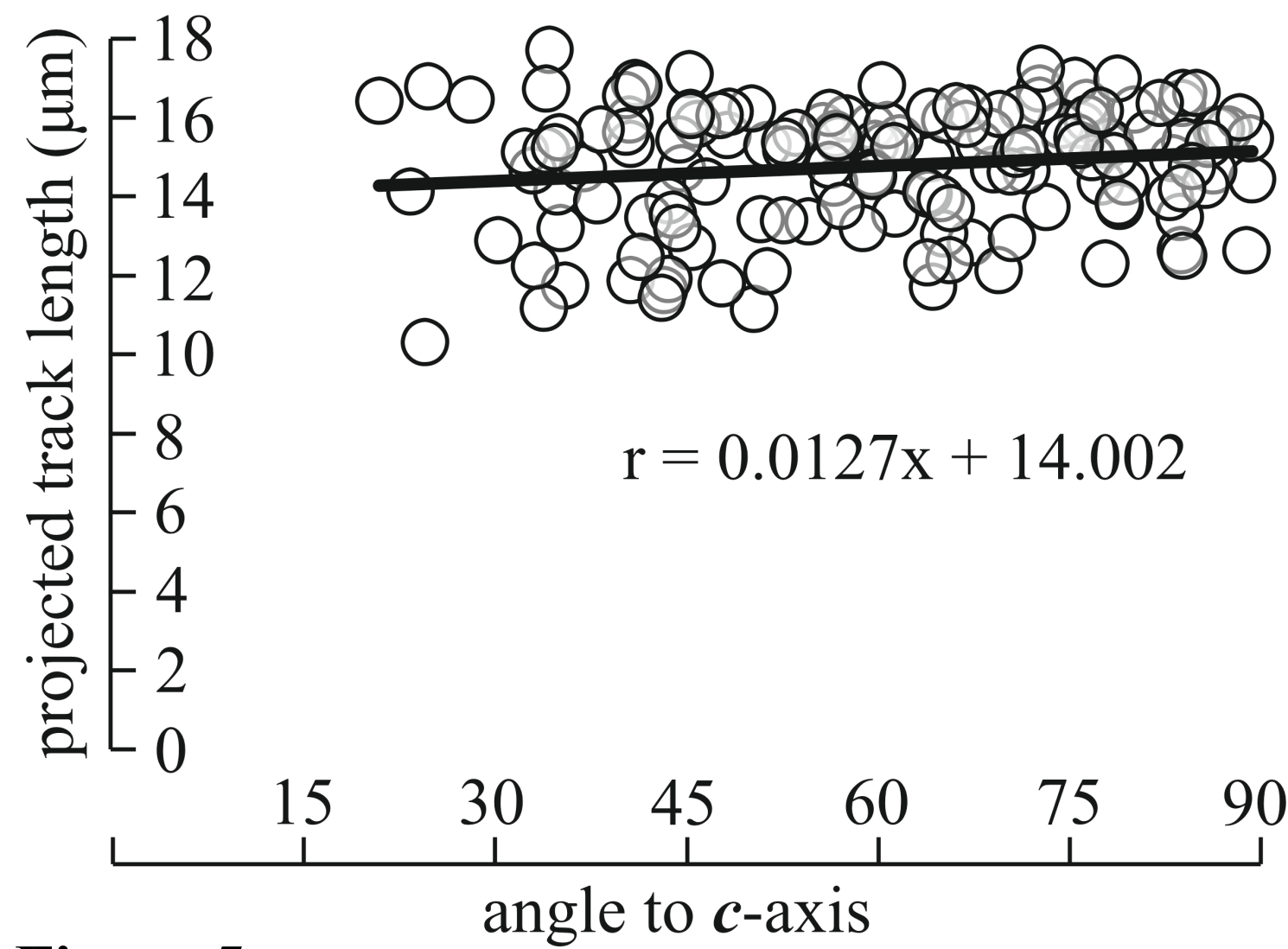
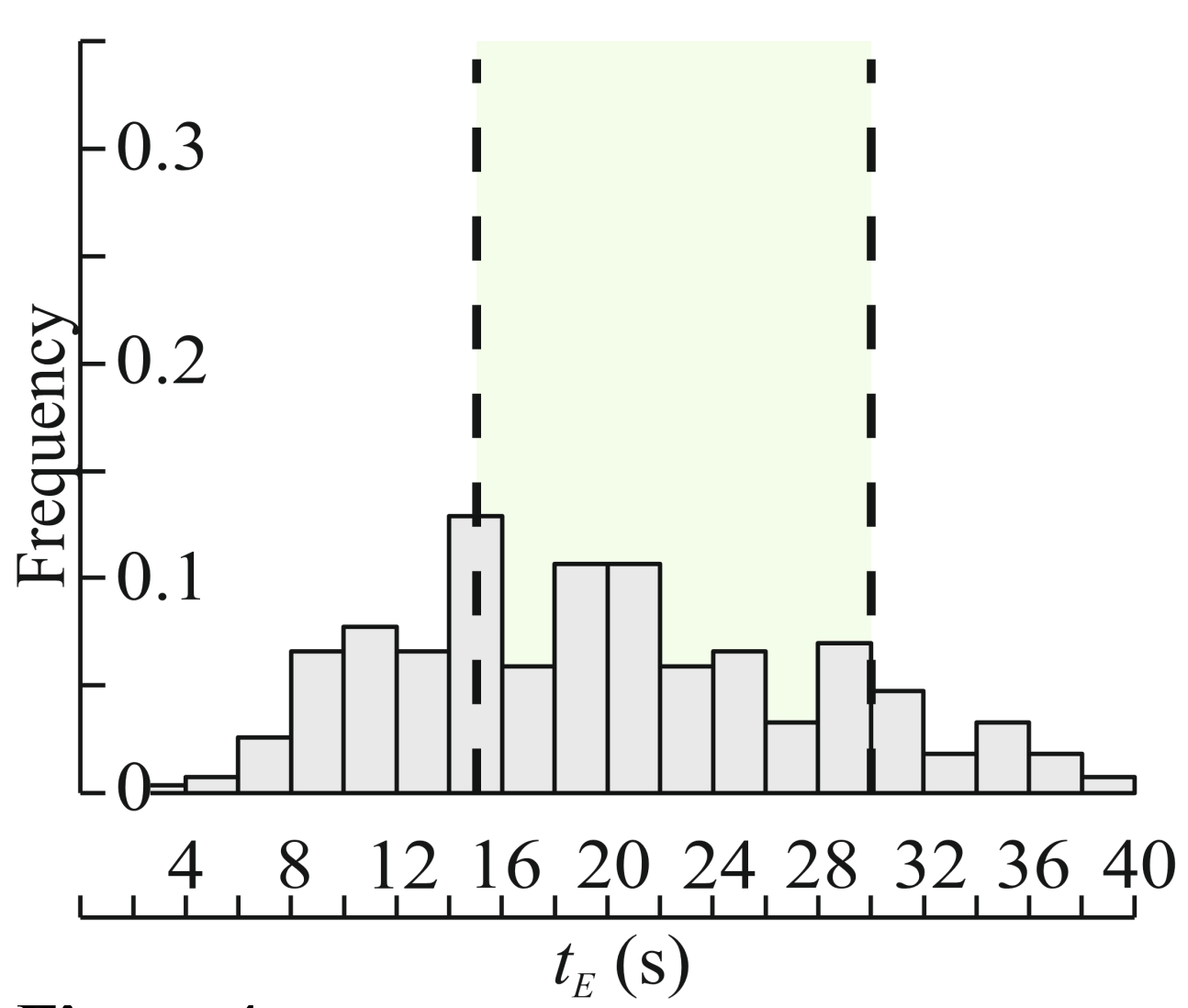
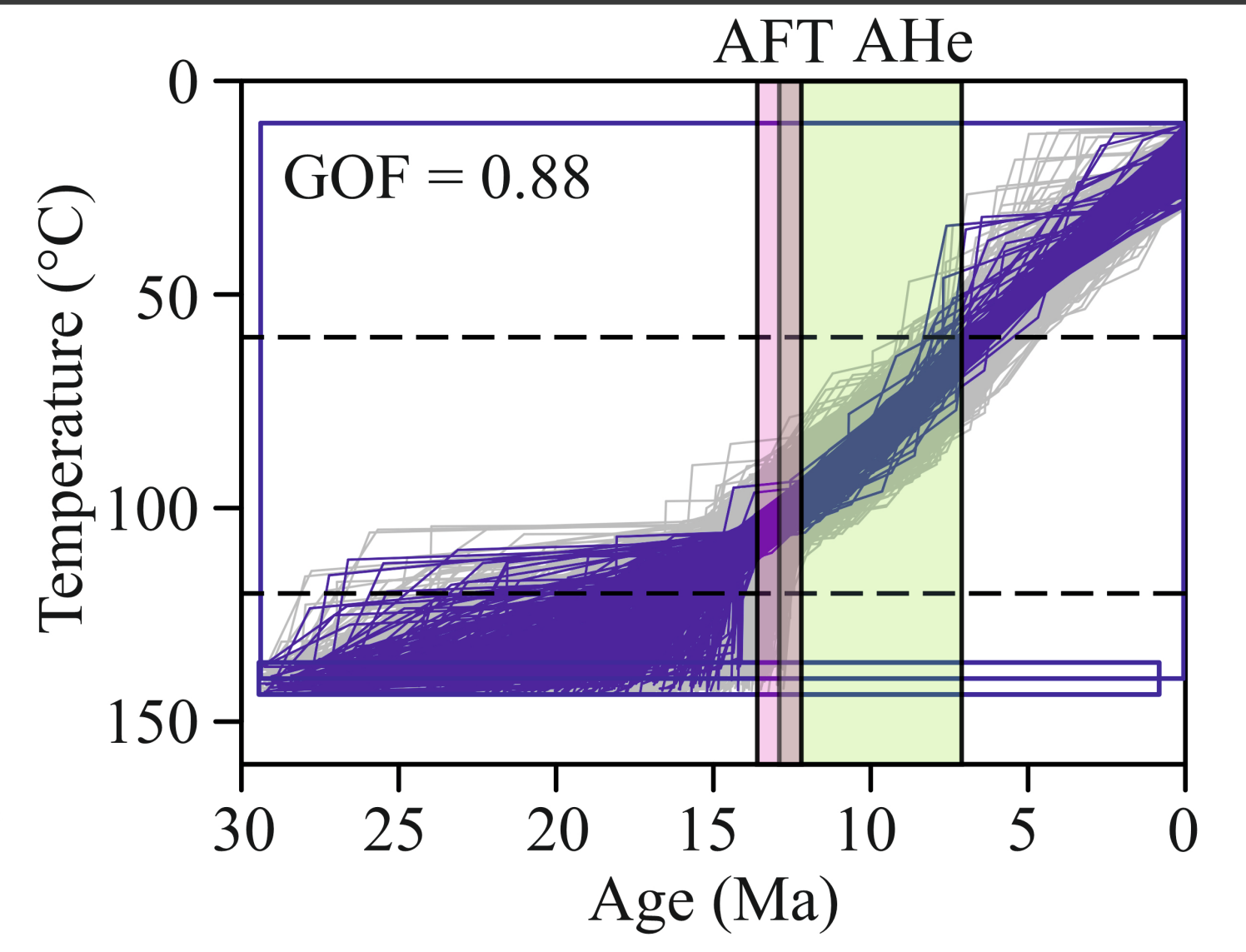
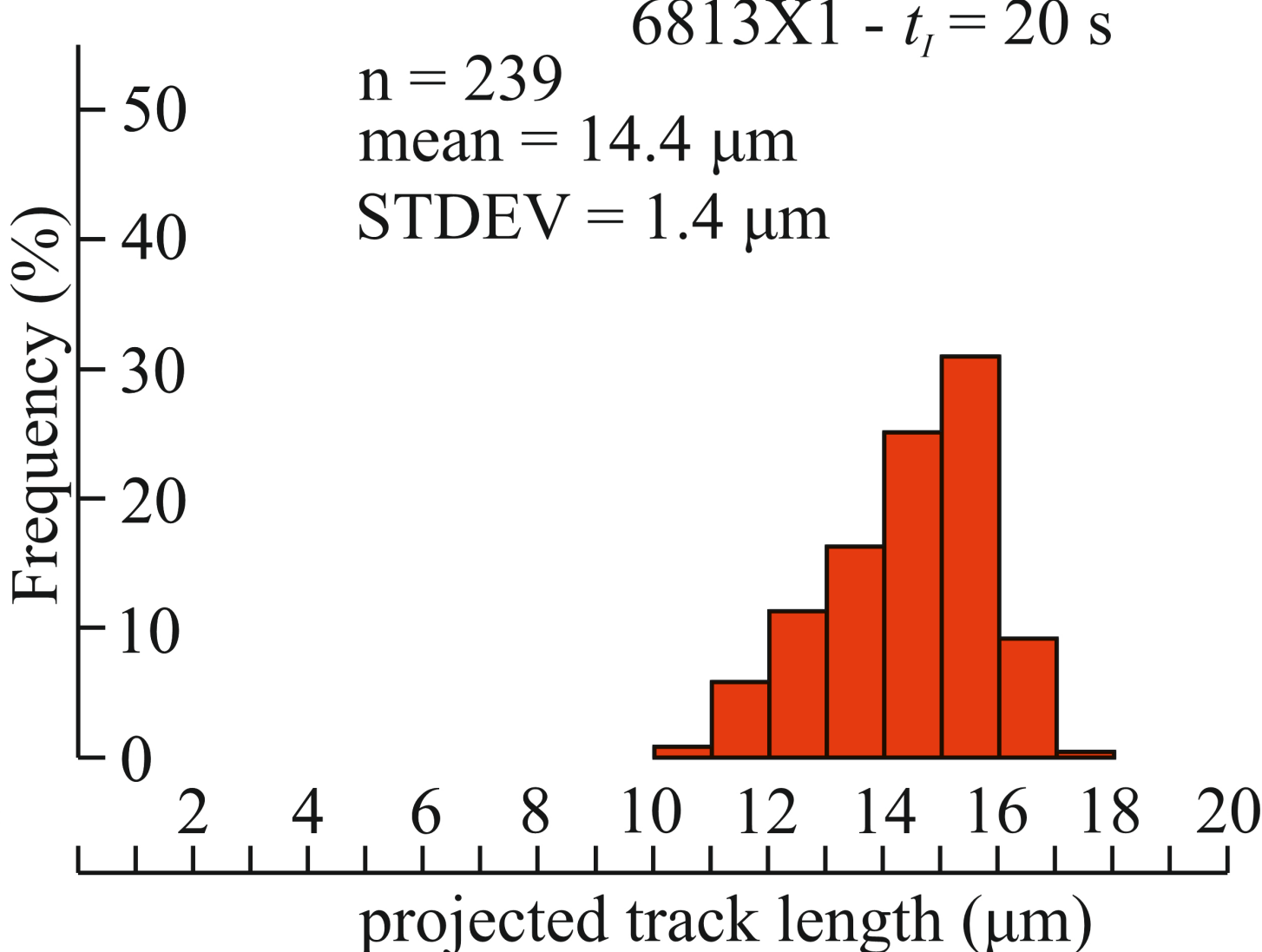
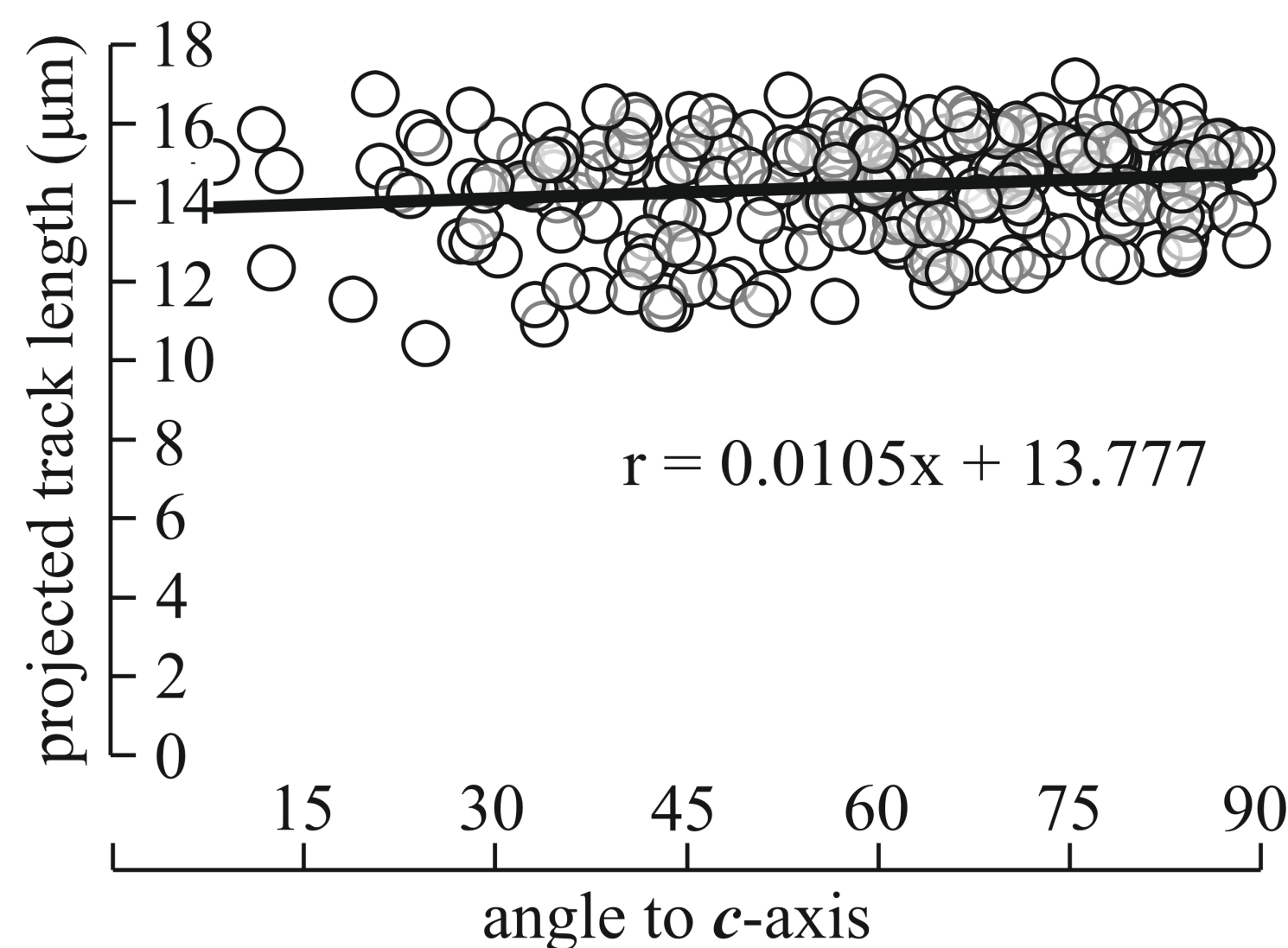
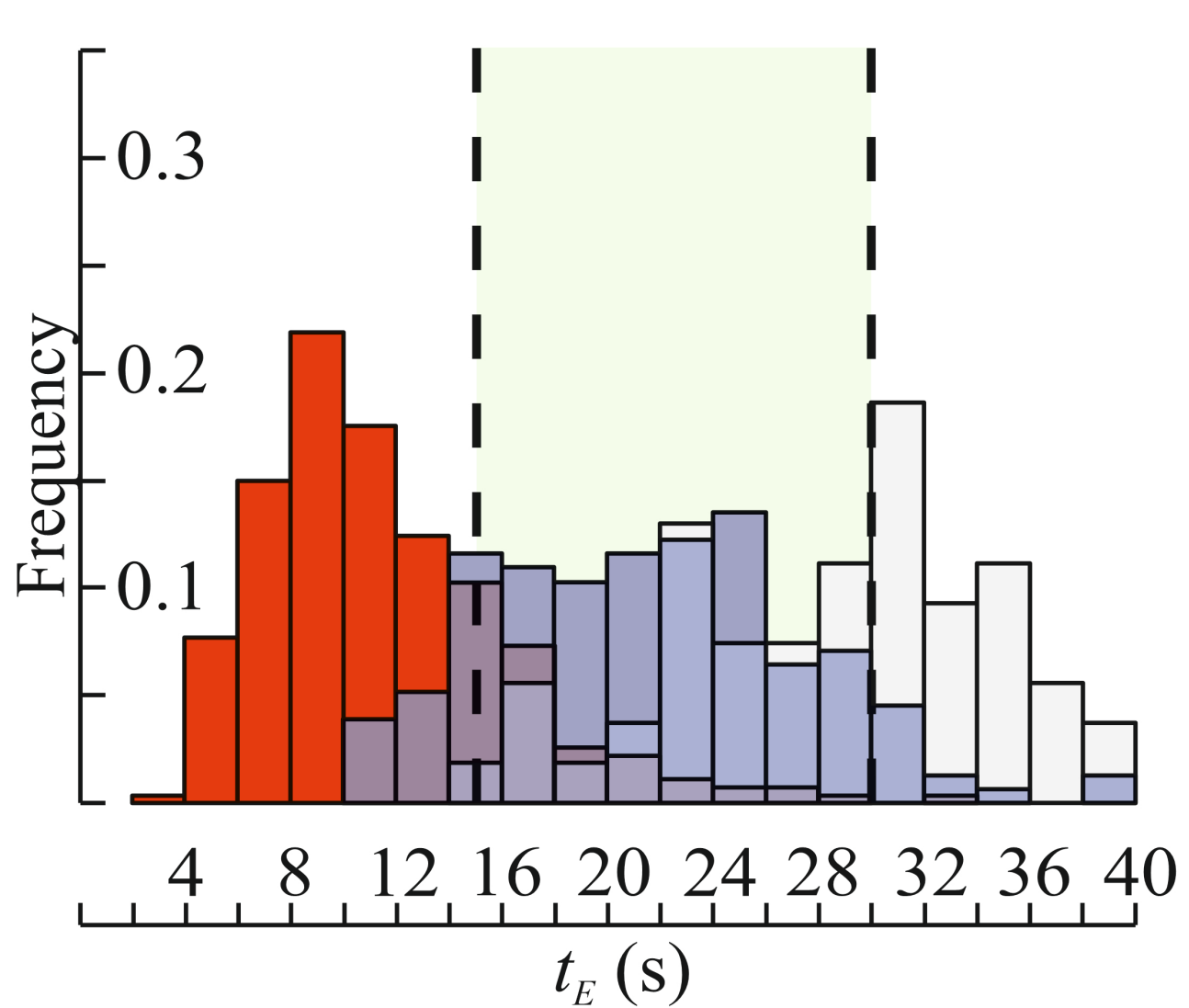


Figure 4.

Figure 5.